

<b>Notice of References Cited</b>	Application/Control No. 09/784,392	Applicant(s)/Patent Under Reexamination PEDERSON ET AL.	
	Examiner Chongshan Chen	Art Unit 2172	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,544,359	08-1996	Tada et al.	707/202
*	B	US-5,864,849	01-1999	Bohannon et al.	707/8
*	C	US-5,832,508	11-1998	Sherman et al.	707/200
*	D	US-6,112,287	08-2000	Litaize et al.	712/11
*	E	US-6,408,341	06-2002	Feeney et al.	709/250
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	O					
	P					
	Q					
	R					
	S					
	T					

**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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